

Docket No.: 060188-0031



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Response Under 37 CFR 1.116 - Expedited Procedure

: Customer Number: 20277

Kentaro SHIOMI, et al.

: Confirmation Number: 6677

Application No.: 09/779,440

: Group Art Unit: 2132

Filed: February 09, 2001

: Examiner: Jung W. Kim

For: LSI DESIGN METHOD AND VERIFICATION METHOD

Mail Stop Af  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.  
☐ Applicant is entitled to small entity status under 37 CFR 1.27  
☐ Also attached:

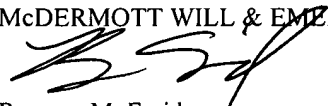
The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	6	20	0	\$50.00 =	\$0.00
Independent Claims	1	7	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

  
Ramyar M. Farid  
Registration No. 46,692

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**Date: September 14, 2006**

**Please recognize our Customer No. 20277 as our  
correspondence address.**



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	: Customer Number: 20277
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**AMENDMENT UNDER 37 CFR 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 14, 2006, having a three-month shortened statutory period for response set to expire on September 14, 2006, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.